F-8744

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Norio OHTAKE, et al.

Serial No.

UNKNOWN (U.S. National Stage of

PCT/JP2004/000093 filed January 9, 2004)

Filed

July 8, 2005

For

PRODUCING METHOD AND PRODUCING

APPARATUS OF NUCLEAR SPIN POLARIZED

XENON GAS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is an Information Disclosure Citation together with copies of the documents referred to therein. The degree of relevance of the documents referred to in the Information Disclosure Citation is set forth in the (International/Japanese) Search Report also submitted herewith except for D. Raftery, High-Field NMR of Adsorbed Xenon Polarized by Laser Pumping, Physical Review Letters, 1991, vol. 66, No. 5, pages 584 to 587 which will be submitted separately.

Respectfully submitted,

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		AATION DISCLOSURE CITATION Use several sheets if necessary)	Filing Date: July 8, 2005		Group:			
U.S. PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
		US- 5,545,396	8/13/1996	Albert et al.	ļ			
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
		JP- 11-248809	9/17/1999	JP			Y*	
TRANSLATION KEY: * English Abstract. F Concise statement of relevance provided in foreign search report. C Concise statement of relevance provided in specification. C Concise statement of relevance provided in IDS. P Relevant portion of reference translated. English abstract only - copy of reference in pct search. OTHER INFORMATION DISCLOSURE CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)								
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								